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Under the Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it contains a valid OMB control number. Complete if Known Substitute for form 1449A/PTO PINFORMATION DISCLOSURE 10/625,737 **Application Number** July 24, 2003 Filing Date STATEMENT BY APPLICANT Koji DAIRIKI First Named Inventor 3 1 2006 (use as many sheets as necessary) 2822 **Group Art Unit** Maria Guerrero **Examiner Name** of **Attorney Docket Number** 1 0756-7176

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